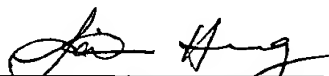




1744

In re application of: SZETSEN STEVEN LEE et al.
Application No.: 09/849,136
Filed: May 04, 2001
For: HIGH EFFICIENCY SCRUBBER FOR WASTE
GAS ABATEMENT
Examiner:
Art Unit:

I hereby certify that this correspondence
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Jiawei Huang, Reg. No. 43,330

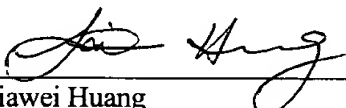
ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Sir:

Transmitted herewith is a certified copy of Taiwan Application No. 90106865 filed on **March 23, 2001**.

A return prepaid postcard and a Request for Changing Correspondence address are also included herewith.

It is believed no fee is due. However, the Commissioner is authorized to charge any fees required, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 50-0710 (Order No. JCLA7097). A duplicate copy of this sheet is enclosed.


Jiawei Huang
Registration No. 43,330

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